

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yoshifumi Sato

Case No.: 09792909-5777

Serial No.: 10/762,696

Examiner: Rod Thomas Van Roy

Filed: January 22, 2004

Group Art Unit: 2828

For: SEMICONDUCTOR LASER
ELEMENT AND METHOD OF
FABRICATION THEREOF

AMENDMENT A

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

S I R:

This amendment is being filed in response to the Office Action dated March 16, 2006.
Please reconsider the application in view of the amendment and remarks presented below.